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This listing of claims will replace all prior versions and listings of the claims in the application.

In the Claims:

- 1. (Currently amended) The housing assembly heating device of Claim 5 wherein the liner is removable from the susceptor without requiring disassembly of the susceptor.
- 2. (Currently amended) The housing assembly heating device of Claim 1 including:
 - a first susceptor portion and a second susceptor portion disposed on opposed sides of the processing chamber;
 - a first liner disposed between the first susceptor portion and the processing chamber; and
 - a second liner disposed between the second susceptor portion and the processing chamber.
 - 3. (Currently amended) The housing assembly heating device of Claim 5 wherein the susceptor includes a platter region, the housing assembly further including:
 - a platter adapted to support the article disposed in the processing chamber and overlying the platter region; and
 - an opening defined in the liner and overlying the platter region.
- 4. (Currently amended) The housing assembly heating device of Claim 5 wherein the liner varies in thickness along at least a portion of its length.
- 5. (Currently amended) A <u>heating device</u> housing assembly for an induction heating device, the housing assembly defining a processing chamber and comprising:

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a housing assembly defining a processing chamber and including:

- a) a susceptor surrounding at least a portion of the processing chamber; and
- b) a thermally conductive liner interposed between the susceptor and the processing chamber, wherein the liner is separately formed from the susceptor;
- e) wherein the susceptor includes a susceptor core of a first material and a susceptor coating of a second material;
- wherein the second material is selected from the group consisting of refractory metal carbides; and
- e) wherein the liner is interposed between the susceptor coating and the processing chamber; and

an EMF generator configured to generate an electromagnetic field to induce eddy currents within the susceptor, wherein the susceptor converts the eddy currents to heat.

- 6. (Currently amended) The housing assembly heating device of Claim 5 wherein the second material is TaC.
- 7. (Currently amended) The housing assembly heating device of Claim 5 wherein the first material is graphite.
- 8. (Currently amended) The housing assembly heating device of Claim 3 wherein the platter region is exposed through the opening in the liner.
- 9. (Currently amended) The housing assembly heating device of Claim 3 wherein the platter is received in the opening in the liner.
- 10. (Currently amended) The housing assembly heating device of Claim 3 wherein the platter is adapted to rotate relative to the susceptor.

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11. (Currently amended) The housing assembly heating device of Claim 4 wherein the liner contacts the susceptor.

12. (Currently amended) The housing assembly heating device of Claim 5 wherein the liner includes a portion formed of SiC interfacing with the processing chamber.